

Application No.: Not Yet Assigned

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Docket No.: 02157/0202679-US0

**AMENDMENTS TO THE SPECIFICATION**

Please amend the title as follows:

ELECTRON BEAM IRRADIATION APPARATUS, ELECTRON BEAM IRRADIATION  
METHOD, AND APPARATUS FOR AND METHOD OF MANUFACTURING DISC-SHAPED  
OBJECT

Following the title, please insert the following paragraphs:

**Cross-Reference to Prior Application**

This is a U.S. National Phase application under 35 U.S.C. §371 of International Patent Application No. PCT/JP2003/011890, filed September 18, 2003, and claims the benefit of Japanese Patent Application Nos. 2002-274120, filed September 19, 2002 and 2002-274121, filed September 19, 2002, all of which are incorporated by reference herein. The International Application was published in Japanese on April 1, 2004 as WO 2004/027520 A1 under PCT Article 21(2).

Please replace the sub-title in page 31, line 5 with the following amended sub-title:

--Detailed Description of Best Mode for Carrying out the Invention--

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